#### Physics Seminar DESY Zeuthen, March 28, 2007

# The CDF Silicon Detector Design Operations Studies



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#### **Making Use of Silicon Detectors**



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#### Precision tracking

- Momentum measurement = measurement of track curvature: dominated by larger tracking device, e.g. drift chamber
- Impact parameter = closest distance between track helix and z-axis: need precision tracking point close to primary interaction

#### B-tagging

- Decays of long-lived *B* mesons ( $c \approx 500 \ \mu m$ ) lead to displaced vertices
- Identification of *b*-jets: displaced secondary vertex (cut on decay length significance)

#### **Double-Tag Event in Layer 00** of CDF Silicon Detector jet Number of Jets = 4 Run 178855 Missing Et = 45 GeV Event 5504617 Muon Pt = 37 GeV X b-tag iet b-tag Missing ET jet Tagged Jet 1: Et = 11 GeV, Phi = 79, L2d = 7 mm agged Jet 2: Et = 38 GeV, Phi = 355, L2d = 1 mm let

### Silicon in HEP: A Little History



- Today: Silicon detectors standard tool for precision tracking and vertexing (esp. secondary vertex heavy flavor tagging)
- First particle physics application of silicon detectors: high-rate fixed target experiments for charm physics (esp. D meson lifetimes)
  - CERN NA11 (ACCMOR Collaboration): ~1983
  - Fermilab E691 (Tagged Photon Spectrometer): ~1985
- Silicon microstrip vertex trackers at electron-positron colliders (1990s)
  - All LEP detectors, Mark-II at SLC
  - B factories



- First application in a hadron collider (CERN Spps): UA2 (1987)
  - Single cylinder of silicon pads  $(8.7 \times 40 \text{ mm}^2)$ : 60 cm long, 14.7 cm radius, 1 m<sup>2</sup> of sensor surface, mounted directly on the beam pipe

## Silicon Detector in CDF Run I a



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- First ideas in 1983
- Concept of silicon detectors at hadron colliders controversial within CDF (e.g.: occupancy of inner layers too high?)
- First design: SVX (operated 1992–1993)
  - 2 barrels with 4 layers each, 51.1 cm long, radii: 3–8 cm
  - Single sided sensors (60 µm pitch), DC-coupled readout
  - Short lifetime mainly due to radiation damage to the readout chip: increased occupancy, reduced efficiency



#### **But Nevertheless...**



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#### ARTICLES

#### Evidence for top quark production in $\overline{p}p$ collisions at $\sqrt{s} = 1.8$ TeV

F. Abe,<sup>13</sup> M. G. Albrow,<sup>7</sup> S. R. Amendolia,<sup>23</sup> D. Amidei,<sup>16</sup> J. Antos,<sup>28</sup> C. Anway-Wiese,<sup>4</sup>
G. Apollinari,<sup>26</sup> H. Areti,<sup>7</sup> P. Auchincloss,<sup>25</sup> M. Austern,<sup>14</sup> F. Azfar,<sup>21</sup> P. Azzi,<sup>20</sup> N. Bacchetta,<sup>18</sup>
W. Badgett,<sup>16</sup> M. W. Bailey,<sup>24</sup> J. Bao,<sup>34</sup> P. de Barbaro,<sup>25</sup> A. Barbaro-Galtieri,<sup>14</sup> V. E. Barnes,<sup>24</sup> B. A. Barnett,<sup>12</sup> P. Bartalini,<sup>23</sup> G. Bauer,<sup>15</sup> T. Baumann,<sup>9</sup> F. Bedeschi,<sup>23</sup> S. Behrends,<sup>2</sup> S. Belforte,<sup>23</sup> G. Bellettini,<sup>23</sup> J. Benljamin,<sup>32</sup> J. Benlloch,<sup>15</sup> J. Bensinger,<sup>2</sup> D. Benton,<sup>21</sup> A. Beretvas,<sup>7</sup> J. P. Berge,<sup>7</sup> S. Bertolucci,<sup>8</sup> A. Bhatti,<sup>26</sup> K. Biery,<sup>11</sup> M. Binkley,<sup>7</sup> F. Bird,<sup>29</sup> D. Bisello,<sup>20</sup> R. E. Blair,<sup>1</sup>
C. Blocker,<sup>29</sup> A. Bodek,<sup>25</sup> V. Bolognesi,<sup>23</sup> D. Bortoletto,<sup>24</sup> C. Boswell,<sup>12</sup> T. Boulos,<sup>14</sup> G. Brandenburg,<sup>9</sup>
E. Buckley-Geer,<sup>7</sup> H. S. Budd,<sup>25</sup> K. Burkett,<sup>16</sup> G. Busetto,<sup>20</sup> A. Byon-Wagner,<sup>7</sup> K. L. Byrum,<sup>1</sup> C. Campagnari,<sup>7</sup> M. Campbell,<sup>16</sup> A. Caner,<sup>7</sup> W. Carithers,<sup>14</sup> D. Carlsmith,<sup>33</sup> A. Castro,<sup>20</sup> Y. Cen,<sup>21</sup> F. Cervelli,<sup>23</sup> J. Chapman,<sup>16</sup> M.-T. Cheng,<sup>28</sup> G. Chiarelli,<sup>8</sup> T. Chikamatsu,<sup>31</sup> S. Cihangir,<sup>7</sup> A. G. Clark,<sup>23</sup> M. Cobal,<sup>23</sup> M. Contreras,<sup>5</sup> J. Conway,<sup>27</sup> J. Cooper,<sup>7</sup> M. Cordelli,<sup>8</sup> D. P. Coupal,<sup>20</sup> D. Crane,<sup>7</sup> J. D. Cunningham,<sup>2</sup>
T. Daniels,<sup>15</sup> F. DeJongh,<sup>7</sup> S. Delchamps,<sup>7</sup> S. Dell'Agnello,<sup>23</sup> M. Dell'Orso,<sup>23</sup> L. Demortier,<sup>26</sup> B. Denby,<sup>23</sup> M. Deninno,<sup>3</sup> P. F. Derwent,<sup>16</sup> T. Devlin,<sup>27</sup> M. Dickson,<sup>25</sup> S. Donati,<sup>23</sup> R. B. Drucker,<sup>14</sup> A. Dunn,<sup>16</sup> K. Einsweiler,<sup>14</sup> J. E. Elias,<sup>7</sup> R. Ely,<sup>14</sup> E. Engels, Jr.,<sup>22</sup> S. Eno,<sup>5</sup> D. Errede,<sup>10</sup> S. Errede,<sup>10</sup> Q. Fan,<sup>25</sup> B. Farhat,<sup>15</sup> I. Fiori,<sup>3</sup> B. Flaugher,<sup>7</sup> G. W. Foster,<sup>7</sup> M. Franklin,<sup>9</sup> M. Frautschi,<sup>18</sup> J. Freeman,<sup>7</sup> J. Friedman,<sup>15</sup> H. Frisch,<sup>5</sup> A. Fry,<sup>29</sup> T. A. Fuess,<sup>1</sup> Y. Fukui,<sup>13</sup> S. Funaki,<sup>31</sup>
G. Gagliardi,<sup>23</sup> S. Galeotti,<sup>23</sup> M. Gallinaro,<sup>02</sup> A. F. Garfinkel,<sup>24</sup> S. Geer,<sup>7</sup> D. W. Gerdes,<sup>16</sup> P. Giannetti,<sup>23</sup> N. Giokaris,<sup>26</sup> P. Giromini,<sup>8</sup> L. Gladney,<sup>21</sup> D. Glenzinski,<sup>12</sup> M. Gol

#### ... The Top!

#### time, temperature, bias voltage)

#### Silicon Detector in CDF Run I b

- Second attempt: SVX' (operated 1993–1996)
  - Mechanical design similar to SVX, slightly smaller inner radius (2.8 cm)
  - Radiation hard readout chip
  - AC-coupled readout with FOXFET (Field Oxide FET) biasing
  - Signal-to-noise ratio (SNR) decreases faster than expected (attributed to FOXFET biasing)
  - Reduction of SNR partly compensated by changes in detector operation (integration time, temperature, bias voltage)





#### **Run I: Lessons Learnt**



- Secondary vertex *b*-tagging:
  - Efficiency drops quickly for SNR smaller than approx. 3
  - But: top quark discovery with data taken with SNR of 6 → 3
- Detector resolution:
  - Great impact parameter (SVX' only: 35 µm, 46 µm including beam spot)
  - Poor p<sub>T</sub> resolution: short lever arm, radii: 3–8 cm
     → additional layer at larger radius (~20 cm)
- Some limitations can be overcome by clever software (and people)



For more details on the history of Silicon detectors in CDF (and CMS):

J. Incandela, Life on the Critical Path

(talk given at the 6th International "Hiroshima" Symposium, Carmel, CA, September 11–15, 2006)

### **Tevatron Run II: 2001–2009**



- Proton-antiproton collider,  $\sqrt{s} = 1.96$  TeV
- 36×36 bunches
- Collisions every 396 ns
- Record instantaneous peak luminosity:
   292 µb s<sup>-1</sup> (10<sup>30</sup> cm<sup>-2</sup> s<sup>-1</sup>)
- Luminosity goals:
  - Instantaneous: 300–400 µb s<sup>-1</sup>



- Integrated: 6–8 fb<sup>-1</sup> until 2009
- Two multi-purpose experiments: CDF & DØ

#### **Integrated Luminosity**



- Tevatron continues to perform very well
  - More than 2.6 fb<sup>-1</sup> delivered
  - More than 2.1 fb<sup>-1</sup> recorded by CDF



#### **The CDF Detector**





### **CDF Trigger Overview**





- Level 1 Trigger:
  - Synchronous hardware trigger
  - Input rate: 1.7 MHz
- Level 2 Trigger:
  - Hardware & software triggers
  - Input rate: up to 35 kHz
- Level 3 Trigger:
  - PC farm
  - Input rate: up to 1 kHz
- Special role of Silicon detector due to Silicon Vertex Trigger (SVT)
  - Silicon information used in SVT, i.e. at Level 2
    - → must be read out at Level 1

### **Silicon Detectors in CDF**



- 7–8 silicon layers (6 m<sup>2</sup>)
- 722,432 readout channels on 5,456 readout chips
- Three sub-detectors:
  - SVX II
  - Intermediate Silicon Layers (ISL)
  - Layer 00 (L00)
- Purpose:
  - Precision tracking
  - Reconstruction of primary and secondary vertices



#### **SVX II: The Core Detector**



- Mechanical structure:
   3 barrels with 6 bulkheads,
   12 wedges each (1m long)
- 5 layers of double-sided silicon sensors at radii of 2.5–10.6 cm
  - Layers 0, 1, 3 (Hamamatsu): axial and 90° strips
  - Layers 2 and 4 (Micron): axial and 1.2° stereo strips
  - Strip pitch: 60–140 µm
  - AC-coupled readout: microdischarges limit bias voltage to 170 V (Hamamatsu) and 80 V (Micron)





#### **SVX and SVT**



- Silicon Vertex Trigger (SVT):
  - Fast track reconstruction and cut on impact parameter at trigger level
  - Essential for trigger on hadronic *B* decays
- Requirements for using SVX II in the SVT:
  - Easy geometrical mapping: symmetric 12-fold wedge structure
  - Full SVX II data available at L2: fast readout
  - Tight alignment constraints: SVX II must be parallel to the beam to within 100  $\mu rad$

Wedge



#### **ISL: The Extension**





J. Goldstein: "Don't mess with my detector!"

- One central layer (lηl < 1): link tracks from SVX II to wire chamber
- Two forward layers (1 < lηl < 2): tracking at large pseudorapidities
- Strip pitch: 112 µm



#### **ISL and Forward Tracking**

- Traditional "Outside-In" tracking in CDF: COT tracks extrapolated to SVX II
- Silicon stand-alone tracking: poor momentum resolution
- New "Backward" tracking:
  - Make full use of ISL acceptance up to lηl < 2</li>
  - Seed Silicon tracking from inner axial superlayers of the COT





### **Material Budget and Longevity**



- Poor impact parameter resolution for low-p<sub>T</sub> tracks
- Affects also high-p<sub>T</sub> physics: need low-p<sub>T</sub> tracks for btagging
- LHC-style radiation-hard silicon not yet available when SVX II was designed
  - Inner layers may die of radiation damage
- Solution: Layer 00
  - New low-mass layer directly on the beam pipe
  - Use radiation-hard silicon

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### L00: The Beam Pipe Layer

- Material budget:
  - Goal: 0.01 X<sub>0</sub> (achieved)
  - Below r = 2 cm, 0.01  $X_0$  of additional material does not matter
- Material and radiation:
  - Remove readout electronics from tracking volume
  - Transmit analog signals to chips
- Single-sided "LHC style" sensors:
  - Non-oxygenated (Hamamatsu, SGS Thomson)
  - Oxygenated (Micron)
- Actively cooled support structure
- Strip pitch: 25 µm, every second strip read out



Insertion of L00: 300 µm clearance!







- Discovery of B<sub>s</sub>
  oscillations:
  Phys. Rev. Lett. 97
  (2006) 242003
- Layer 00 makes the difference: uncertainty on oscillation amplitude reduced by factor of >2  $\rightarrow$  5 $\sigma$  discovery instead of 3 $\sigma$  evidence
- Achieved decay time resolution of  $\sigma_t = 90$  fs (1/4 of measured oscillation period)
- Resolution corresponds to approx. 27 µm decay length resolution

## Silicon DAQ: A Simplified View



- Main components:
  - Silicon Readout Controller (SRC): "brain" of the system
  - Fiber Interface Board (FIB): control signals and optical readout
  - Portcard: chip commands and optical transmitters (DOIMs)

### **SVX3D Readout Chip**



- Integrated analog front-end and digital back-end
- Fast: capable of running at 132 ns clock rates
- Deadtimeless: can collect charge and digitize simultaneously
- Dynamic pedestal subtraction
  - On-chip subtraction of common mode noise (defined as number of ADC counts measured in 31st lowest channel)
- On-chip sparsification
  - Removes channels below programmable threshold
  - Reduces data rate and readout time
- Honeywell radiation-hard CMOS 0.8 µm process, irradiated with:
  - 40 kGy with 60Co source: 17% chip noise increase
  - 150 kGy with 55 MeV Proton source

#### 53 MByte/s Data Out





### **Cooling & Interlocks**



- Readout electronics develops
   3.5 kW of heat
- Low temperatures are beneficial for Silicon sensors:
  - Reduction of thermal noise
  - Mitigation of radiation damage
- Solution: operate Silicon detectors at –10 °C (SVX II/L00) and +6 °C (ISL, electronics)
- Protect Silicon by interlock system based on Programmable Logic Controller
  - Monitor several 100 process parameters: temperatures, pressures, flows, dew points, chiller status
  - Trip chillers & power supplies in unsafe situations



#### **Beam Abort System**

- Monitoring of instantaneous and integrated dose rate by four Beam Loss Monitors (BLM)
- CAMAC logic triggers beam abort if dose rate > 0.12 Gy/s
- Current time resolution (210 µs = 10 Tevatron revolutions) too slow for some beam incidents
- BLM/diamond upgrade (currently being commissioned)
  - Faster VME electronics:
     21 µs = 1 revolution
  - Smaller & closer to Silicon real estate: polycrystalline CVD diamond detectors





BLM

**New BLM** 

Beam pipe

BLM













#### **Expect the Unexpected**



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#### Timeline:

- R&D: 4 years
- Production & Installation: 1 year
- Commissioning: 1.5 years
- Various problems encountered initially:
  - Power supply burn-out
  - Blocked cooling lines in ISL
  - Noise pickup on L00
  - Wirebond resonance problems
  - Beam incidents
- All of the above problems have been addressed: detector is in good shape



#### **Wirebond Resonances**



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- Symptom: mysterious loss of *z* sides
- Reason (reproduced on test bench):
  - Wires in jumper to connect *r*-φ and *z* sides are perpendicular to magnetic field → Lorentz force
  - Highest current during readout
  - Resonance frequency around 20 kHz
- Preventing further losses:
  - Dedicated VME board to measure  $\Delta t$ between subsequent readout commands  $\rightarrow$  stop data-taking if more than 13 readout commands with the same  $\Delta t$  occur
  - Limit L1 trigger rate to < 35 kHz
- ATLAS and CMS learnt the lesson:
  - Resonance protection board (ATLAS)
  - Potted wires (CMS)









![](_page_30_Picture_2.jpeg)

![](_page_30_Picture_3.jpeg)

![](_page_30_Picture_4.jpeg)

![](_page_31_Picture_0.jpeg)

![](_page_32_Figure_0.jpeg)

#### Maintenance is a Challenge

![](_page_33_Picture_1.jpeg)

- A complex system...
  - 722,000 channels
  - 5,400 chips
  - 135 VME boards in 17 crates
  - 114 power supplies in 16 crates
  - Cooling & interlocks
  - Lots of cables
  - ... and not very accessible:
    - Power supplies and part of DAQ in collision hall
  - Detector and portcards: inaccessible

![](_page_33_Picture_12.jpeg)

#### No Ladder Left Behind\*

- Maintain constant high efficiency due to aggressive "No Ladder Left Behind" policy:
  - Vigilant monitoring: spot problems early (digital errors, ADC spectra, ...)
  - Detailed logging of problems occuring
  - "Quiet time studies":
    - Diagnose problems  $\rightarrow$  fix or mitigate
    - Attempts to revive dead ladders
  - Collision hall access between stores
    - Diagnosis: cable swaps, light level measurements, ...
    - Swap DAQ boards, power supplies, optical receivers, …
- Extremely successful, but personpower intensive: need 4–6 FTE

![](_page_34_Picture_11.jpeg)

\*coined by R. Wallny, UCLA, see No Child Left Behind Act of 2001 (US Public Law 107-110)

![](_page_35_Figure_0.jpeg)

![](_page_36_Figure_0.jpeg)

- Very stable efficiency after commissioning, average: 95%
- Define efficiency as close as possible to standard CDF tracking:
  - Denominator: muons from  $J/\psi \rightarrow \mu\mu$  with muon ID and COT track which cross at least 3 layers of SVX II
  - Numerator: Silicon added to COT track by standard pattern recognition, at least 3 layers with hits in SVX II/L00

#### There are Problems, too...

- Radiation-related:
  - Single-event upsets in collision hall DAQ boards (approx. 1 per day)
  - FPGA burnout (1–2 per year)
  - Power supply failures: corrupted readback of voltages and currents, spontaneous switch-offs, loss of CAENet communication
- Cooling and interlocks: chiller wear and tear, air leaks, frozen cooling lines, humidity sensor problems, ...
- Beam incidents:
  - 2–3 MJ of beam energy: spray of secondary particles can cause significant damage
  - Examples: magnet quenches, RF station loss, beamseparator sparks, spontaneous ramping of abort kicker magnets

![](_page_37_Figure_9.jpeg)

![](_page_37_Picture_10.jpeg)

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![](_page_37_Picture_12.jpeg)

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![](_page_38_Figure_0.jpeg)

#### **Lessons Learnt**

![](_page_39_Picture_1.jpeg)

[...] because as we know, there are known knowns; there are things we know we know. We also know there are known unknowns; that is to say we know there are some things we do not know. But there are also unknown unknowns – the ones we don't know we don't know. (D. Rumsfeld, 2002) Expect surprises during commission and operation

- Keep expertise around, good documentation
- Eliminate single points of failure: what can break will break
- Spares, spares, spares...
- Don't forget infrastructure: cables, power supplies, cooling, ...
- It's a hadron collider, dude! Don't underestimate radiation-induced failures and beam incidents

### **Quo Vadis, CDF?**

- Tevatron scheduled to run through FY 2009
- Planning for the future is taking place now
- Higher luminosities: challenge for detector & trigger
  - Parallelize Silicon readout: additional readout crate (Oct 2006)
  - Optimize chip working point, e.g. digitization thresholds
- Fewer people: challenge for detector operations
  - Shift crew reduced from 4 to 3 persons (Dec 2006)
  - Automation of standard procedures and safety systems

![](_page_40_Picture_10.jpeg)

![](_page_40_Picture_11.jpeg)

### **CDF Silicon Workshop 2006**

![](_page_41_Picture_1.jpeg)

![](_page_41_Picture_2.jpeg)

May 2006: Silicon workshop at UC Santa Barbara

#### Goals:

- Education of Silicon group
- Knowledge transfer from the "old guys"
- Attract new people for the Silicon group
- Comprehensive program:
  - Silicon detectors of the past, present, and future
  - All about CDF Silicon
  - Whale watching, wine...
  - See: <u>http://b0sili01.fnal.gov/</u> si\_workshop2006/

![](_page_42_Picture_0.jpeg)

![](_page_42_Picture_1.jpeg)

![](_page_42_Picture_2.jpeg)

### **Silicon Detector Longevity**

![](_page_43_Picture_1.jpeg)

- Performance of key components decreases with irradiation, main concern: Layer 0 of SVXII
  - Noise increase
    - Bulk damage of sensors: increased leakage currents & capacitance
    - Electronics: chip damage, capacitance
- Signal degradation
  - Charge trapping in crystal defects: decreased charge collection efficiency
  - Bias voltage limited: underdepletion of sensors

Component	Performance after 8 fb <sup>-1</sup>
Optical Transmitters	10% degradation of light level, no change in wave form
SVX3D Readout Chip	17% noise increase
Silicon Sensors	This talk

#### Signal-to-Noise Ratio

![](_page_44_Picture_1.jpeg)

- Two main sources of noise:
  - Sensor shot noise ( $I_{\text{leak}}$  = leakage current):  $Q_{\text{shot}} = 900 e^{-1} \sqrt{I_{\text{leak}}} (\mu \text{A})$
  - Chip noise ( $C_{chip}$  = chip capacitance):  $Q_{chip} = f_1(\Phi) + f_2(\Phi) C_{chip}$ Test beam data: 17% increase of chip noise after 8 fb<sup>-1</sup>

Direct measurement from data:

![](_page_44_Figure_6.jpeg)

#### CDF II Preliminary

- Dataset: first 1.7 fb<sup>-1</sup> (164 pb<sup>-1</sup> from commissioning period excluded)
- Signal: path-length corrected charge sum of clusters using hits on tracks (*J/ψ* data)
- Noise: single-channel noise (calibration data)

#### square-root increase with Integrated Luminosity (fb<sup>-1</sup>) luminosity Physics Seminar DESY Zeuthen, March 28, 2007 – U. Husemann: The CDF Silicon Detector

### **Signal and Noise Models**

**CDF II Preliminary** 

- Signal definition: most probably value of fit to ADC spectrum (Landau distribution convoluted with Gaussian)
- Data suggest linear decrease with **luminosity**

![](_page_45_Figure_4.jpeg)

![](_page_45_Figure_5.jpeg)

- Noise definition: mean strip noise obtained from calibration runs (taken every 2 weeks)
- Assumption: shot noise dominant source of noise:

![](_page_45_Picture_8.jpeg)

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#### **SNR & Lifetime Projections**

- Fit with signal & noise model, large extrapolation to 8 fb<sup>-1</sup>
  - Limit I: *SNR* = 8 (SVT efficiency)
  - Limit II: SNR = 6–3 (*b*-tagging)
- Bottom line: detector lifetime seems not to be limited by SNR degradation
- More definite prediction with more data and refined modeling
- Cross-check: SNR projection from bias current measurement consistent with direct measurement

![](_page_46_Figure_8.jpeg)

![](_page_46_Picture_9.jpeg)

#### **Depletion Voltage**

![](_page_47_Picture_1.jpeg)

- Due to radiation damage: evolution of voltage needed to fully deplete sensor
  - Effective number of charge carriers N<sub>eff</sub> reduced until type inversion: decreasing depletion voltage
  - Increasing depletion voltage after type inversion, eventually reaching maximum allowed bias voltage

#### Depletion Voltage Evolution in SVX II Layer 0

![](_page_47_Figure_6.jpeg)

S. Worm, Lifetime of the CDF Run II Silicon, VERTEX 2003

Predictions: modified Hamburg model:  $\Delta V_{dep} \propto \Delta N_{eff} = N_A + N_C + N_Y$ 

$$N_{A} = \Phi \sum_{i} g_{0,i} \exp[-c_{A,i}(T)t]$$
  

$$N_{C} = N_{C,0} (1 - \exp[-c\Phi]) + g_{c}\Phi$$
  

$$N_{Y} = g_{Y}\Phi \left(1 - \frac{1}{1 + g_{Y}\Phi c_{Y}(T)t}\right)$$

**Beneficial Annealing** 

Stable Component

**Reverse Annealing** 

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#### Method 1: Signal vs. Bias

- Dedicated data-taking runs ("Signal Bias Scans")
  - Study collected charge of silicon hits from good tracks during colliding beams operation
  - Find peak of ADC spectrum as a function of bias voltage (fit: Landau Second Gaussian)
  - Determine V<sub>dep</sub> as 95% amplitude of sigmoid fit
- Works for entire detector, but consumes valuable beam time

![](_page_48_Figure_7.jpeg)

![](_page_48_Picture_8.jpeg)

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#### Method 2: Noise vs. Bias

- \* "Noise Bias Scans": study average noise as a function of bias voltage
- Measurement idea: inter-strip thermal noise on *n* side cleared by applying bias voltage
   → depleted detector has lower noise level
- Works only for double-sided sensors (i.e. SVX II and ISL)
- Advantage: does not require beam in accelerator
   → no interference with datataking
- Expect problems with this method after type inversion (no p stops on p<sup>+</sup> side)

![](_page_49_Figure_7.jpeg)

![](_page_49_Picture_8.jpeg)

### **Lifetime Projection for Layer 0**

![](_page_50_Picture_1.jpeg)

![](_page_50_Figure_2.jpeg)

- SVX II Layer 0: first layer to hit maximum bias voltage
- Currently: Layer 0 close to type inversion
- Data follows optimistic scenario: L0 will outlast CDF Run II

## **Lifetime Projection for Layer 00**

![](_page_51_Picture_1.jpeg)

![](_page_51_Figure_2.jpeg)

Layer 00: very close to the beam, but built from "radiation-hard" silicon

Evolution of depletion voltage:

- Type inversion around 1 fb<sup>-1</sup> (except oxygenated sensors)
- Minimum depletion voltage around 35 V
- Very consistent increase after type inversion
- Layer 00 will outlast CDF Run II

#### Summary

![](_page_52_Picture_1.jpeg)

- Silicon detectors in CDF: SVX II, ISL, and L00
  - Large and complex system: 6 m<sup>2</sup> of sensors, 722k channels
  - Very stable performance after long commissioning period
  - Essential for CDF's physics program
- LHC detectors have profited (and will further profit) from Tevatron experience, especially for Silicon detectors
- The CDF Silicon group is very active:
  - Detector maintenance and day-to-day operations
  - Detailed studies of performance and longevity
- Tevatron runs until 2009: CDF will go for the Higgs, and the Silicon is ready to go!

![](_page_53_Picture_0.jpeg)